



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yoshiyuki Tanaka et al. Atty. Docket No. 075834.00111

Serial No.: 09/ 955,810 Group Art Unit: 2825

Filed: September 19, 2001 Examiner: Calvin Lee

Invention: "PRODUCTION METHOD OF SEMICONDUCTOR DEVICE"

DRAWING AMENDMENT

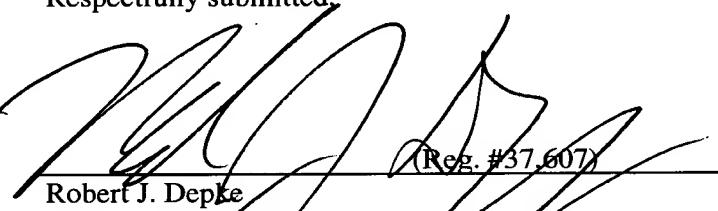
Commissioner of Patents
Alexandria, VA 22213-1450

ATTN: Official Draftsman

SIR:

Applicants have attached a copy of Applicants' proposed changes to Figures 4B and 6-11 of the referenced application. The proposed changes are indicated in red ink. Applicants respectfully request that the changes be accepted and entered in this application. Applicants state that formal drawings with the proposed changes set forth therein will be submitted upon receiving a Notice of Allowance for this application.

Respectfully submitted,


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Date: May 5, 2003

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Depke
5/14/03
3/0/03

#9/Title-11
Drawings
5/14/03
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TECHNOLOGY CENTER 2800